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Application Number	09/327,826					
Filing Date	June 8, 1999					
First Named Inventor	JIAN					
Group Art Unit	2874					
Examiner Name	Not Yet Known					
Attorney Docket Number	2790-P001					

				U.S. PATENT DOCU	IMENTS	
Examiner Initials*	Cite No.1	U.S. Paten Number	Kind Code ²	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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